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FROM: Cameron K. Kerrigan

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E-MAIL: ckerrigan@ssd.com

RE: Status of Application

U.S. Patent Application Serial No. 10/550,153

Our File 038915.00045

Message: Dear Sirs,

It appears that our 5/22/08 request to correct the filing date on the filing receipt (attached) has not yet been approved, however we have received no communication informing us as to its status.

If you could please advise us as to the status of the request, we would be very appreciative.

Best Regards,

Tawny Cothran for Cameron Kerrigan, Reg. No. 44826.

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Attorney Docket No. 38915.45

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Examiner:

Toshikazu Okubo, et al.

Khiem D. Nguyen

Serial No.

10/550,153

Art Unit:

2823

Filed:

September 20, 2005

Confirmation No: 1053

Title:

Method for Analyzing Copper Electroplating Solution, Apparatus for the

Analysis, and Method for Fabricating Semiconductor Product

Commissioner for Patents P.O. Box 1450

Alexandria, VA 22313-1450

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REQUEST FOR CORRECTED FILING RECEIPT

Dear Sir:

Applicant respectfully requests corrections to the Filing Receipt for the above-identified patent application. The errors are shown on the Filing Receipt as well as described below.

The error occurred in the following data:

Ш	Omitted Applicant(s)
	Name of inventor
	Applicant's address
	Attorney Docket No.
$\overline{\boxtimes}$	Title
	Filing Date
	Application Number
	Domestic Priority Data as Claimed by Applicants
	Foreign Applications
$\overline{\Box}$	Other

in that the Filing Receipt should read as follows:

Page 1

SANFRANCISCO/264137.1

Attorney Docket No. 38915.45

TITLE:

Method for Analyzing Electrolytic Coppor Plating Solution, and Analyzing Device therefore and Production Method for Somi Conductor Product Analyzing Copper Electroplating Solution, Apparatus for the Analysis, and Method for Fabricating Semiconductor Product

FILING DATE:

09/20/2005 09/19/2005

A copy of the Filing Receipt with the changes noted thereon is enclosed. Also enclosed is a date stamped copy of the United States Postal Service Express Mail Label.

If for any reason an insufficient fee has been paid, please charge the insufficiency to Deposit Account No. <u>07-1850</u>.

Date: May 22, 2008

Respectfully submitted,

Squire, Sanders & Dempsey LLP One Maritime Plaza, Suite 300 San Francisco, CA 94111 Telephone (415) 954-0200 Facsimile (415) 393-9887

/Song Zhu, Reg. No. 44,420/ Song Zhu, Ph.D. Reg. No. 44,420

Page 1 of 3





Inited States Patent and Trademark Office

APPL NO.	FILING OR 371 (c) DATE	ART UNIT	FIL FEE REC'D	ATTY,DOCKET N	0	DRAWINGS	TOT CLMS	IND CLMS
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	,		BY: TOP	Ally: ()	~	Date I	Mailed: 05	5/12/2006

Receipt is acknowledged of this regular Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please mall to the Commissioner for Patents P.O. Box 1450 Alexandria Va 22313-1450, Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

Applicant(s)

Toshikazu Okubo, Tokyo, JAPAN; Katsuyoshi Naoi, Tokyo, JAPAN; Yuka Yamada, Tokyo, JAPAN;

Power of Attorney: The patent practitioners associated with Customer Number 44955.

Domestic Priority data as claimed by applicant

This application is a 371 of PCT/JP04/03934 03/23/2004

Foreign Applications

Acceptable Request to Retrieve Priority Application Received?

JAPAN 2003-082037 03/25/2003 JAPAN 2003-350544 10/09/2003

МО

If Required, Foreign Filing License Granted: 05/11/2006

The country code and number of your priority application, to be used for filing abroad under the Paris Convention, is US10/550,153

Projected Publication Date: 08/17/2006

Non-Publication Request: No

Page 2 of 3



45

Early Publication Request: No

Method for Analyzing Copper Electroplating Solution, Apparatus for the Analysis, and
Method for Fabricating Semiconductor Product

Method for analyzing electrolytic copper plating solution, and analyzing device therefor and production method for semi-conductor product

Preliminary Class

438

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Since the rights granted by a U.S. patent extend only throughout the territory of the United States and have no effect in a foreign country, an inventor who wishes patent protection in another country must apply for a patent in a specific country or in regional patent offices. Applicants may wish to consider the filling of an international application under the Patent Cooperation Treaty (PCT). An international (PCT) application generally has the same effect as a regular national patent application in each PCT-member country. The PCT process simplifies the filling of patent applications on the same invention in member countries, but does not result in a grant of "an international patent" and does not eliminate the need of applicants to file additional documents and fees in countries where patent protection is desired.

Almost every country has its own patent law, and a person desiring a patent in a particular country must make an application for patent in that country in accordance with its particular laws. Since the laws of many countries differ in various respects from the patent law of the United States, applicants are advised to seek guidance from specific foreign countries to ensure that patent rights are not lost prematurely.

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Applicants may wish to consult the USPTO booklet, "General Information Concerning Patents" (specifically, the section entitled "Treaties and Foreign Patents") for more information on timeframes and deadlines for filing foreign patent applications. The guide is available either by contacting the USPTO Contact Center at 800-786-9199, or it can be viewed on the USPTO website at http://www.uspto.gov/web/offices/pac/doc/general/index.html.

For information on preventing theft of your intellectual property (patents, trademarks and copyrights), you may wish to consult the U.S. Government website, http://www.stopfakes.gov. Part of a Department of Commerce initiative, this website includes self-help "toolkits" giving innovators guidance on how to protect intellectual property in specific countries such as China, Korea and Mexico. For questions regarding patent enforcement issues, applicants may call the U.S. Government hotline at 1-866-999-HALT (1-866-999-4158).

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Title 35, United States Code, Section 184
Title 37, Code of Federal Regulations, 5.11 & 5.15

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	Date Mailed: Sept. 19, 2005	By: AW/if	PTO DATE STAMP:	
	Application No.: Not Yel Assigned		Filling Date: September 19, 2005	
	Applicant: Toshikazu OKUBO et e	!	Docket No.: 38915.00045	
	Title: METHOD FOR ANALYZIN	G COPPER ELECT	ROPLATING SOLUTION, APPARATUS FOR THE	
	ANALYSIS, AND METHOD	FOR FABRICATIN	G SEMICONDUCTOR PRODUCT	
	The following has been received in	the U.S. Palent Offic	e on the date stamped hereon:	
	Patent Application 50 Pages	21 Claims	☐ Response/Amendment	
1	Drawings 9 Sheets		☐ Preliminary Amendment	
1	☐ General Authorization for Extens	ions of Time	☐ Request for Continued Examination	
Į	☑ Oath/Declaration		☐ Pelltion for Extension of Time	
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	☑ Transmittal Form (in duplicate)	•	Copy of Notice of Missing Requirements	
	Fee Transmittal (in duplicate)		Replacement Drawings Shoets	
	Provisional Application Pages		☐ Issue Fee Transmittal (PTO-85b)	
	Design Application Pages	Drawings '	☐ Request to Correct Filing Receipt	
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